

LASER INTENSITY ADJUSTING METHOD

BACKGROUND OF THE INVENTION

Field of the Invention

5 The present invention relates to a laser intensity
adjusting method to be applied to an electrophotographic
digital image forming apparatus of a digital copying
apparatus, a digital printer or the like. More specifi-
cally, the present invention relates to a laser intensity
10 adjusting method of adjusting the maximum intensity of laser
light for irradiating the photoreceptor presenting a
uniform potential given by the corona discharger, such that
the potential of a photoreceptor portion exposed to laser
of the maximum intensity is equal to a predetermined set
15 potential.

Description of Related Art

In an image forming apparatus of a digital copying
apparatus or the like, there is conducted, regularly or as
necessary, a so-called potential correction for making
20 correction such that the potential of the photoreceptor
surface is equal to a predetermined value. The potential
correction includes a so-called dark potential correction
and a so-called residual potential correction. The dark
potential correction refers to correction in which, with
25 the photoreceptor not exposed to laser, the potential is

corrected by adjusting the bias voltage of the grid of the corona discharger. The residual potential correction refers to correction in which, with the photoreceptor exposed to laser, the potential is corrected by adjusting
5 the maximum intensity of the laser light. Generally, residual potential correction is to be conducted in succession after dark potential correction.

Fig. 4 schematically illustrates the arrangement of an image forming apparatus A of a color digital copying
10 apparatus, in the vicinity of the photoreceptor thereof.

The image forming apparatus A has at its center a drum-like photoreceptor 1. Disposed around the photoreceptor 1 are a corona discharger 2 for giving a predetermined uniform potential to the surface of the photoreceptor 1,
15 a laser exposure unit 8 (of which laser light is shown by an arrow of L) for causing a surface portion of the photoreceptor 1 to be exposed to the laser light based on an image read by an image reading device (not shown), a potential sensor 3 for measuring the surface potential of
20 the photoreceptor 1, developing units 4a - 4d for developing an electrostatic latent image on the surface of photoreceptor 1 formed by its exposure to the laser light of the laser exposure unit 8 (the developing units 4a - 4d arranged to respectively form toner images of yellow, cyanogen, magenta and black), a transferring belt 5 for
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transferring, to transfer paper, the toner images on the photoreceptor 1 surface formed by the developing units 4a - 4d, and a cleaning unit 6 for cleaning residual toner remaining on the photoreceptor 1 surface. These component
5 elements above-mentioned are disposed in this order in the rotational direction of the photoreceptor 1 or in the direction of an arrow Y1.

The following description will discuss the operational procedure of dark potential correction and
10 residual potential correction with reference to Figs. 5 and 6.

At the dark potential correction (Step S51), the bias voltage of the grid of the corona discharger 2 is set to an optional value, and the potential (dark potential) of
15 the photoreceptor 1 surface is measured by the potential sensor 3 with the photoreceptor 1 not exposed to the laser exposure unit 8. Based on a difference between the measured dark potential and the desired preset potential, using a relationship equation (linear equation) obtained through
20 experiments or the like, the bias voltage is adjusted such that the dark potential is equal to the desired preset potential. The dark potential correction is relatively readily conducted in the manner above-mentioned because the relationship between the grid bias voltage and the surface
25 potential of the photoreceptor 1 can be approximated using

a substantially straight line function.

In succession, residual potential correction is to be conducted on the photoreceptor 1 which has just been subjected to dark potential correction. The maximum
5 intensity of the laser exposure unit 8 is set to an optional value (for example ① in Fig. 6), and then the surface of the photoreceptor 1 presenting a uniform potential given by the corona discharger 2 is exposed to the laser light of the laser exposure unit 8 (Steps S52 and S53). Then,
10 the potential (residual potential) of the photoreceptor 1 surface is measured by the potential sensor 3 (Step S54). A linear equation (③ in Fig. 6) previously obtained through experiments or the like is then applied to the measured residual potential (② in Fig. 6) to calculate the laser
15 intensity (⑤ in Fig. 6) for the desired preset potential (④ in Fig. 6) (Step S56). The laser intensity thus obtained is set as the maximum intensity (Step S57), and the operations of steps S53 - S57 are repeated until the residual potential obtained at the step S54 becomes substantially
20 equal to the desired preset potential (Step S55).

The foregoing conventional residual potential correction is disadvantageous in view of much labor and time required. More specifically, according to the conventional residual potential correction, the solution is

searched using a linear equation previously obtained through experiments or the like. However, the actual relationship between laser intensity and residual potential is as shown in Fig. 6, and it is therefore difficult to linearly approximate this relationship. Thus, although the laser maximum intensity is gradually converged to the solution by repeating the steps S53 - S57, repeated operations are required in a large number of iteration times before the final solution is obtained.

10 SUMMARY OF THE INVENTION

It is an object of the present invention to provide a laser intensity adjusting method capable of readily making a residual potential correction in a shorter period of time.

The present invention provides a laser intensity adjusting method of adjusting the maximum intensity of a laser exposure unit for irradiating laser light to the photoreceptor surface to which a uniform potential is being given by a corona discharger, such that the potential of the photoreceptor portion exposed to laser of the maximum intensity is equal to a predetermined preset potential. According to the present invention, photoreceptor surface portions are exposed to laser lights of a plurality of laser intensities obtained by coarsely dividing a predetermined laser intensity, and the potentials of the photoreceptor surface portions exposed to the laser lights of the

plurality of laser intensities are detected (coarse-division potential detecting step). In the vicinity of the laser intensity corresponding to the potential which is the nearest to the predetermined set potential, out of the potentials detected at the coarse-division potential detecting step, the predetermined laser intensity is further finely divided to set a plurality of laser intensities, photoreceptor surface portions are exposed to laser lights of the plurality of laser intensities thus set, and the potentials of the photoreceptor surface portions exposed to the laser lights of the plurality of laser intensities are detected (fine-division potential detecting step). The fine-division potential detecting step is repeated until there is obtained potential equal to or substantially equal to the predetermined set potential, and there is set, as the maximum intensity, the laser intensity corresponding to the potential thus obtained.

According to the laser intensity adjusting method of the present invention, photoreceptor surface portions are exposed to laser lights of a plurality of laser intensities obtained by coarsely dividing an optionally set laser intensity, and the potentials of the photoreceptor surface portions are detected. When there is not obtained the desired preset potential, there are repeated operations of exposing photoreceptor surface portions to laser lights of

procedure of a laser intensity adjusting method of prior art; and

Fig. 6 is a view illustrating the residual potential correction operation of prior art.

5 DESCRIPTION OF THE PREFERRED EMBODIMENTS

The following description will discuss an embodiment of the present invention for better understanding thereof. It is however noted that the following embodiment is a mere example embodying the present invention, and does not limit,
10 in nature, the technical scope thereof.

Fig. 1 is a flow chart illustrating a laser intensity adjusting method according to an embodiment of the present invention; Fig. 2 is a view illustrating an example of exposure portions (patches) formed on the photoreceptor;
15 Fig. 3 is a view illustrating a residual potential correction operation according to the embodiment of the present invention; and Fig. 4 is a side view schematically illustrating the arrangement of an image forming apparatus A of a color digital copying apparatus.

20 Likewise in the method of prior art above-mentioned, the description will be made, in this embodiment of the present invention, of a laser intensity adjusting method which is applied to an image forming apparatus A of a color digital copying apparatus as shown in Fig. 4.

25 The image forming apparatus A has at its center a

drum-like photoreceptor 1. Disposed around the photoreceptor 1 are a corona discharger 2 for giving a predetermined uniform potential to the surface of the photoreceptor 1, a laser exposure unit 8 (of which laser light is shown by an arrow of L) for causing a surface portion of the photoreceptor 1 to be exposed to the laser light based on an image read by an image reading device (not shown), a potential sensor 3 for measuring the surface potential of the photoreceptor 1, developing units 4a - 4d for developing an electrostatic latent image on the surface of photoreceptor 1 formed by its exposure to the laser light of the laser exposure unit 8 (the developing units 4a - 4d arranged to respectively form toner images of yellow, cyanogen, magenta and black), a transferring belt 5 for transferring, to transfer paper, the toner images on the surface of the photoreceptor 1 formed by the developing units 4a - 4d, and a cleaning unit 6 for cleaning residual toner remaining on the surface of the photoreceptor 1. These component elements above-mentioned are disposed in this order in the rotational direction of the photoreceptor 1 or in the direction of an arrow Y1.

The laser exposure unit 8 is arranged such that the laser maximum intensity can optionally be set and that the set maximum intensity (P_{MAX}) can be divided by a predetermined number (1023 in this embodiment) and laser light of each

intensity ($P_{MAX} \times x/1023$) ($x = 0, 1, 2, 3, \dots$) can be irradiated to the photoreceptor 1.

Referring to the flow chart in Fig. 1, the following description will discuss the operational procedure of the laser intensity adjusting method of the present invention.

In a manner similar to that in the prior art, dark potential correction is to be conducted (Step S1). More specifically, the bias voltage of the grid of the corona discharger 2 is set to an optional value, and with the photoreceptor 1 not exposed to the laser exposure unit 8, the potential (dark potential) of the photoreceptor 1 surface is measured by the potential sensor 3. Based on a difference between the measured dark potential and the desired preset potential, using a relationship equation (linear equation) obtained through experiments or the like, the bias voltage is adjusted such that the dark potential is equal to the desired preset potential.

In a subsequent residual potential correction, the maximum intensity P_{MAX} of the laser exposure unit 8 is set (Step S2). This P_{MAX} value is set somewhat high such that it will be higher than the final preset value (unknown). The maximum intensity P_{MAX} thus set is divided by 1023 and some laser intensities are selected at relatively coarse intervals in a range which is considered to contain the final preset value (Step S3). For example, there may be selected

five laser intensities $P_{MAX} \times (920/1023)$, $P_{MAX} \times (940/1023)$,
 $P_{MAX} \times (960/1023)$, $P_{MAX} \times (980/1023)$, and $P_{MAX} \times (1000/1023)$.

In succession, the surface of the photoreceptor 1 is
exposed to laser lights of the laser intensities thus
5 selected (Step S4). More specifically, exposure portions
(patches A1 ~ A5) are continuously formed, by the respective
laser lights of laser intensities, on the surface of the
photoreceptor 1 as shown in Fig. 2 for example. The
potentials (residual potentials) of the respective patches
10 are measured by the potential sensor 3 (Step S5). Fig. 3
shows an example of the measured potentials of the
respective patches. The operations of steps S2 - S5
correspond to a coarse-division potential detecting step
or a first potential detecting step.

15 When there is found, in the measured residual
potentials of the patches, potential equal to or
substantially equal to the desired preset potential (that
is, when a predetermined finish condition is satisfied) (YES
at step S6), the laser intensity for the patch of which
20 potential is equal to or substantially equal to the desired
preset potential is adopted as the final maximum intensity,
and the processing is finished.

On the contrary, when there is not found, in the
measured residual potentials of the patches, potential
25 equal to or substantially equal to the desired preset

potential (that is, when a predetermined finish condition is not satisfied) (NO at step S6), some laser intensities at fine intervals are selected in the vicinity of the laser intensity for the patch of which potential is the nearest to the desired preset potential (Step S7). For example, it is now supposed that the desired preset potential is -200V and the patch A3 presents a residual potential of -198V. In such a case, a region lower than $P_{MAX} \times (960/1023)$ is further finely divided. For example, there are selected five laser intensities $P_{MAX} \times (950/1023)$, $P_{MAX} \times (952/1023)$, $P_{MAX} \times (954/1023)$, $P_{MAX} \times (956/1023)$, and $P_{MAX} \times (958/1023)$. Then, using these laser intensities thus selected, the operations of the steps S4 - S6 are repeated. Thereafter, the step S7 and the steps S4 - S6 are repeated until the finish condition is satisfied at the step S6. The step S7 and the steps S4 - S6 correspond to a fine-division potential detecting step or a second potential detecting step.

When the finish condition is satisfied at the step S6, there is adopted, as the final maximum intensity, the laser intensity for the patch of which residual potential is equal to or substantially equal to the desired preset potential.

According to the laser intensity adjusting method of the embodiment having the arrangement above-mentioned, the photoreceptor 1 surface is exposed to laser lights of a

plurality of laser intensities obtained by coarsely dividing an optionally set maximum intensity P_{MAX} , and the respective potentials are detected. When there is not obtained the desired preset potential, there are repeated
5 operations of exposing photoreceptor 1 surface portions to
laser lights of a plurality of further finely divided laser
intensities and detecting the respective potentials, until there is obtained potential equal to or substantially equal to the predetermined set potential. Thus, no adjustment
10 is made with the use of approximation, but the whole adjustment is made based on actually measured values, enabling an accurate residual potential correction to be readily made with a less number of iteration times.

An embodiment of the present invention has thus been
15 discussed in detail, but this embodiment is a mere specific example for clarifying the technical contents of the present invention. Therefore, the present invention should not be construed as limited to this specific example. The spirit and scope of the present invention are limited only by the
20 appended claims.

This application claims priority benefits under 35
USC Section 119 of Japanese Patent Application Serial No.
H10-109782, filed on April 20, 1998 with the Japanese Patent
Office, the disclosure of which is incorporated herein by
25 reference.